

Notice of References Cited	Application/Control No. 10/035,387	Applicant(s)/Patent Under Reexamination CHAN ET AL.	
	Examiner Huy K. Mai	Art Unit 2873	Page 1 of 1

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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B	US-2003/0025981	02-2003	Ishikawa et al.	359/290
C	US-5,652,672	07-1997	Huignard et al.	359/292
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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